



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Takashi OGURA, et al.

Serial No.: 10/561,608

Group Art Unit: 2814

Filing Date: December 20, 2005

Examiner: Pham, Hoai V.

For: SEMICONDUCTOR DEVICE AND PRODUCTION METHOD THEREFOR

Honorable Commissioner of Patents
Alexandria, Virginia 22313-1450

RESPONSE TO FIRST OFFICE ACTION,
RESTRICTION REQUIREMENT, AND
ELECTION OF SPECIES REQUIREMENT

Sir:

In response to the Office Action dated January 17, 2007, please consider the following:

INTRODUCTORY COMMENTS

Remarks begin on page 2 of this paper.